

Notice of References Cited

Application/Control No.

10/695,961

Applicant(s)/Patent Under
Reexamination
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Examiner

Matthew Landau

Art Unit

2815

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,756,296	06-2004	Heath et al.	438/622
	B	US-6,087,674	07-2000	Ovshinsky et al.	257/2
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Schultze et al., "Regular Nanostructured Systems Formed Electrochemically: Deposition of Electroactive Polybithiophene Into Porouse Silicon"
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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